

Application Data Sheet

Application Information

Application Type:: Regular
Subject Matter:: Utility
Suggested classification::
Suggested Group Art Unit::
CD-ROM or CD-R?:: None
Computer Readable Form (CRF)?:: No
Title:: PLASMA ETCHING APPARATUS WITH
FOCUS RING AND PLASMA ETCHING
METHOD
Attorney Docket Number:: 025311-0109
Request for Early Publication?:: No
Request for Non-Publication?:: No
Suggested Drawing Figure:: 1
Total Drawing Sheets:: 2
Small Entity?:: No
Petition included?:: No
Secrecy Order in Parent Appl.?:: No

Applicant Information

Applicant Authority Type:: Inventor
Primary Citizenship Country:: Japanese
Status:: Full Capacity
Given Name:: Osamu
Family Name:: KOIKE
City of Residence:: Kanagawa
Country of Residence:: Japan

Street of mailing address:: c/o SEMICONDUCTOR LEADING EDGE
TECHNOLOGIES, INC.
292 Yoshida-cho, Totsuka-ku
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Country of mailing address:: Japan

Correspondence Information

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Representative Information

Representative Designation::	Registration Number::	Representative Name::
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Primary	26,874	WILLIAM T. ELLIS
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Primary	32,904	MICHAEL D. KAMINSKI
Primary	34,079	LYLE K. KIMMS
Primary	25,735	KENNETH E. KROSIN
Primary	34,649	JOHNNY A. KUMAR
Primary	19,621	JACK LAHR
Primary	34,371	GLENN LAW
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Primary	28,665	BERNHARD D. SAXE
Primary	27,590	CHARLES F. SCHILL
Primary	25,479	RICHARD L. SCHWAAB
Primary	34,717	MICHELE M. SIMKIN
Primary	25,258	HAROLD C. WEGNER

Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::

Foreign Priority Information

Country::	Application number::	Filing Date::	Priority Claimed::
Japan	2000-372798	12/07/2000	Yes

Assignee Information

Assignee name::

SEMICONDUCTOR LEADING EDGE
TECHNOLOGIES, INC.